



2811

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)

Yehiel et al.)

Application No: 09/821,415)

Filed: March 28, 2001)

For: SEMICONDUCTOR STRUCTURE)
IMPLEMENTING SACRIFICIAL MATERIAL AND)
METHODS FOR MAKING AND IMPLEMENTING THE)
SAME)

Examiner: H.K. Vu

Art Unit: 2811

Docket No: LAM2P246

Date: March 26, 2002

TECHNOLOGY CENTER 2800

#4
APR 10 2002
RECEIVED
GustonCERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on March 26, 2002.

Signed: _____

Kay HarlowREQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST

Commissioner for Patents
Washington, D.C. 20231

Sir:

I hereby **rescind** the previous request that the above-identified application not be published under 35 U.S.C. § 122(b)(2)(B)(ii).

Respectfully submitted,
MARTINE & PENILLA, LLP

Albert S. Penilla, Esq.
Reg. No. 39,487

710 Lakeway Drive, Suite 170
Sunnyvale, CA 94085
(408) 749-6900
Customer Number 25920